



2621

THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Shiro Fujieda.
Serial No.: 09/996,417
Filed: November 28, 2001
For: IMAGE PROCESSING
METHOD AND
APPARATUS
Group Art Unit: 2621
Examiner: D. G. Mariam
Attorney Docket: OMRN P012

CERTIFICATE OF MAILING

Date of Deposit: January 20, 2005

I hereby certify that this correspondence is, on the date shown above, being:

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INFORMATION DISCLOSURE STATEMENT
PURSUANT TO 37 C.F.R. §1.56 AND §§1.97-1.98

Commissioner for Patents
Alexandria, Virginia 22313

Sir:

The following Form 1449 and copies of documents listed thereon are being filed herewith as a Disclosure Statement. Consideration of each of these documents by the Patent Examiner, and the making of each of them of record in the file of this application, are respectfully requested.

Each item of information contained in this information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.

Respectfully submitted,

A handwritten signature in black ink, appearing to read 'Keiichi Nishimura', is positioned above the printed name.

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January 20, 2005
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Form 1449 (Modified) Information Disclosure Statement By Applicant (Use Several Sheets if Necessary)	Atty Docket No. OMRN P012	Application No.: 09/996,417
	Applicant: Shiro Fujieda	Group 2621
	Filing Date November 28, 2001	

U.S. Patent Documents

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub-class	Filing Date
	A						
	B						
	C						
	D						
	E						

Foreign Patent or Published Foreign Patent Application

Examiner Initial	No.	Document No.	Publication Date	Country or Patent Office	Class	Sub-class	Translation	
							Yes	No
	F	11-195127	07/21/99	JP				X
	G	8-315135	11/29/96	JP				X
	H	8-161493	06/21/96	JP				X
	I	9-54892	02/25/97	JP				X
	J	6-76035	03/18/94	JP				X
	K	5-165967	07/02/93	JP				X
	L	9-204419	08/05/97	JP				X
	M	11-232382	08/27/99	JP				X

Other Documents

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
	O	Office Action from Japan Patent Office, Japan Application No. 2001-360985, date mailed November 30, 2004.
	P	
	Q	
Examiner		Date Considered

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.